



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 20, 2026	
IGI Report Number	LG776689810
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	8.16 X 5.68 X 3.55 MM

GRADING RESULTS

Carat Weight	1.04 CARAT
Color Grade	D
Clarity Grade	VS 2

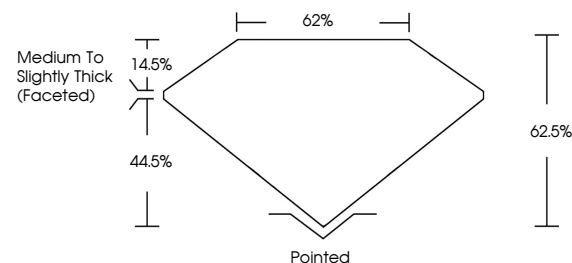
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG776689810

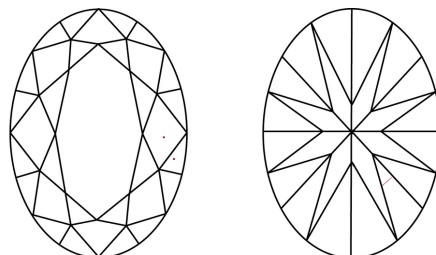
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG776689810
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

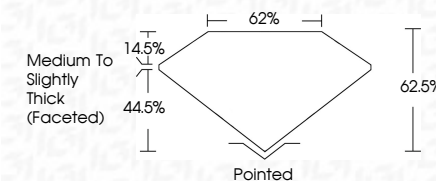
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



February 20, 2026	
IGI Report Number	LG77668910
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	8.16 X 5.68 X 3.55 MM
GRADING RESULTS	
Carat Weight	1.04 CARAT
Color Grade	D
Clarity Grade	VS 2



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG776689810
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.	
Type IIa	



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www.igi.org

January 20, 2025	1.04 CARAT
GI Report No LG77669810	D
DIAL BRILLIANT	VS 2
	62.5%
	62%
	Medium to Slightly Thick (Faceted)
	Ported
	EXCELLENT
	EXCELLENT
	NONE
	681 LG77669810

Comments: This is a very clean diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa